

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S2	7	(((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and ((attach\$4 or detach\$4) near4 (system or apparatus or mechanism)) and (liquid near3 repellent)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:41
S4	3	S3 and ((\$4lithograph \$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and ((attach\$4 or detach\$4) near4 (system or apparatus or mechanism)) and (liquid near3 repellent)).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:48
S3	420	(hiroyuki near3 nagasaka).inv. or (hiroaki near3 takaiwa).inv. or (ryuichi near3 hoshika).inv.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:48
S5	2	(((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and ((attach\$4 or detach\$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support \$4))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:49

S7	2	(((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and (sensor or detector) and ((attach \$4 or detach\$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support\$4 or hold\$4))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:51
S6	3	(((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and (flat near3 surface) and ((attach \$4 or detach\$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support\$4 or hold\$4))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:51
S8	1	(((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and (adhesive) and ((attach\$4 or detach \$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support\$4 or hold\$4))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:52
S9	1	(((\$4lithograph\$4 or exposure) and (projection adj3 (lens or system or apparatus or device)) and ((liquid near3 repellent) near4 (exchang\$4 or detach \$4)) and (exchang\$4 near5 tim\$4))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 13:54

S10	0	(((\$4lithograph\$4 or exposure) and ((liquid or fluid or immersion) near4 (wafer or substrate)) and (((liquid near3 repellent) near4 (judge \$4 or determin\$4)) same (amount or intensity) near4 (light or radiation or illumination))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 14:18
S11	1	(((\$4lithograph\$4 or exposure) and ((liquid near3 repellent) near3 (exchang\$4)) and ((reference adj3 (member or plate)) near4 (liquid near3 repellent))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/02/23 14:21
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L2	0	(((\$4lithograph\$4 or exposure) and ((liquid or fluid or immersion) near4 (wafer or substrate)) and (((liquid near3 repellent) near4 (judge \$4 or determin\$4)) same (amount or intensity) near4 (light or radiation or illumination))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/06/19 22:10
L3	440	(hiroyuki near3 nagasaka).inv. or (hiroaki near3 takaiwa).inv. or (ryuichi near4 hoshika).inv.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/06/19 22:11
L4	1	3 and ((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and (sensor or detector) and ((attach \$4 or detach\$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support\$4 or hold\$4))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/06/19 22:15
L6	3	(((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and (flat near3 surface) and ((attach \$4 or detach\$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support\$4 or hold\$4))))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/06/19 22:17

L7	1	(((\$4lithograph\$4 or exposure) and (projection adj5 (lens or system or apparatus or device)) and ((liquid near3 repellent) near4 (exchang\$4 or detach \$4)) and (exchang\$4 near5 tim\$4))).clm.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2011/06/19 22:19
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EAST Search History (I nterference)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S12	2	"3" and ((\$4lithograph \$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and ((attach\$4 or detach\$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support \$4))).clm.	US-PGPUB; USPAT; UPAD	OR	ON	2011/02/23 13:50
S13	1	"3" and ((\$4lithograph \$4 or exposure) and ((liquid near3 repellent) near3 (exchang\$4)) and ((reference adj3 (member or plate)) near4 (liquid near3 repellent))).clm.	US-PGPUB; USPAT; UPAD	OR	ON	2011/02/23 14:22
S15	1	(((\$4lithograph\$4 or exposure) and ((liquid near3 repellent) near3 (exchang\$4)) and ((reference adj3 (member or plate)) near4 (liquid near3 repellent))).clm.	US-PGPUB; USPAT; UPAD	OR	ON	2011/06/19 14:58

L1	0	(((\$4lithograph\$4 or exposure) and ((liquid or fluid or immersion) near4 (wafer or substrate)) and (((liquid near3 repellent) near4 (judge \$4 or determin\$4)) same (amount or intensity) near4 (light or radiation or illumination))))).clm.	US-PGPUB; USPAT; UPAD	OR	ON	2011/06/19 22:09
L5	3	(((\$4lithograph\$4 or exposure) and ((immersion or liquid or fluid) near5 (substrate or wafer)) and (flat near3 surface) and ((attach \$4 or detach\$4) near4 (system or apparatus or mechanism)) and ((liquid near3 repellent) near5 (stage or base or support\$4 or hold\$4))))).clm.	US-PGPUB; USPAT; UPAD	OR	ON	2011/06/19 22:15

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